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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/3577.X1/DSM/ BCVD/JW	Serial No. 09/336,525
SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT		Applicant Judy Huang	Confirmation No. 7748
(Use several sheets if necessary)		Filing Date June 18, 1999	Group 1762
Examiner M. Padgett			

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
MJP	A1	5,869,147	02/09/1999	König	427	537	04/01/1995
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						
	A9						
	A10						

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Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
MJP	B1	EP 0 785 475 A2	07/23/1997	Europe Hashizume	G03G	5/082	in English	X
	B2	EP 0 194 652	09/17/1986	Europe	C23C	14/06		X
	B3	DE 39 07 857 C1	05/23/1990	Germany	C23C	16/32		X in German
	B4							

OTHER ART

*Examiner Initial		Including Author, Title, Date; Pertinent Pages, Etc.
MJP	C1	Youngsoo Park, et al., Institute of Electrical Engineers, "Endothermic reactions between mullite and silicon carbide in an argon plasma environment," Journal of American Ceramic Society, USA, Jan. 1988; American Ceramic Soc., USA, Vol. 81, No 1, pp. 233-236, XP-002201865. abstract only supplied
	C2	Tremblay, Marc, et al., "Hexagonal Sensor with Imbedded Analog Image Processing for Pattern Recognition," IEEE 1993 Custom Integrated Circuits Conference, May 9, 1993, pp. 12701-12704, XP-000409694.
	C3	Partial European Search Report from EP 00 10 9917, dated July 3, 2002. NOTS applied

Examiner M. Padgett	Date Considered 9/30/02
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.	